

Helmholtz Virtual Institute for
**Memory Effects in Resistive
Ion-beam Modified Oxides**



MEMRIOX International Workshop 2016

25 – 27 September 2016

Berghotel Bastei, Germany



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Venue and organization

Venue

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Agenda
 Place: Berghotel Bastei, 01847 Lohmen
 updated: 21.09.2016 (PZ)
Sunday, 25 September 2016

Start	Who	Durat.	Short Title (Full titles see next page)	Notes
10:30 / 09:45			Transfer from Pirna / Hiking from Rathen	
12:00			Arrival/Lunch Buffet	
13:30	S. Gemming		Welcome address	Chair: C. Ronning
13:40	M. Kats	40+10	Tunable mid-infrared photonics with phase-transition materials	
14:30	S. Slesazeck	30+10	The negative aspects at the origin of hysteresis effects in FeFETs and Nb switches	
15:15		30	Break	
15:45	R. Waser	40+10	Redox-based memristive switching in metal oxides	Chair: B. Abendroth
16:40	H. Schmidt	30+10	Analog resistive oxide switches for neuromorphic computing and fuzzy logics	
17:30			Individual discussions, e.g. follow-up projects	
19:00			Dinner	

Monday, 26 September 2016

6:30			Sunrise Walk (Ferdinandstein, 10 min., sunrise at 6:56) individual	
8:45	M. DiVentra	40+10	Memcomputing: a brain-inspired topological computing paradigm	Chair: H. Schmidt
9:35	T. You	30+10	Non-volatile resistive switching in BiFeO ₃ -based thin films + application	
10:15		30	Break	
10:45	Y.-H. Chu	40+10	Controllable Conduction at Complex Oxide Interfaces	Chair: S. Gemming
11:35	S. Slesazeck (2)	30+10	The diversity of Nb ₂ O ₅ -based Memristors	
12:30			Lunch	
14:00		60	Poster session and Coffee	11 Posters
15:00			Break	
15:30	A. McLeod	40+10	Insulator-metal phase coexistence probed by cryogenic near-field microscopy	
16:20	J. Rensberg	30+10	In-situ electrical characterization of ion beam irradiated VO ₂ structures	
17:15			Sunset Walk (Bastei Bridge/ Neurathen castle, sunset at 18:53) indiv.	
19:30			Dinner	

Tuesday, 27 September 2016

8:30			Check-Out (latest 10:30)	
8:45	B. Abendroth	30+10	Electronic transport properties of ALD thin films TiO ₂ -SrTiO ₃	Chair: H. Stöcker
9:25	S. Krüger	20+10	Technology Transfer, Validation and Exploitation	
10:00			Break	Chair: P. Zahn
10:30	M. Wuttig	40+10	Novel Phase Change Materials by Design: The Mystery of Resonance Bonding	
11:25	S. Gemming	30+10	MEMRIOX: 5 th anniversary	
12:05	S. Gemming	20	Final Discussion & Closing Remarks	
12:30			Lunch	
14:00			Departure	

Breakfast will be served from 7:00.

Invited Talks

Chu, Ying-Hao (p. 4)

Controllable Conduction at Complex Oxide Interfaces

DiVentra, Massimiliano (p. 5)

Collective behavior of physisorbed active elements on Graphene: from 2D superconducting transitions to neural network bio-applications

Kats, Mikhail (p. 6)

Tunable mid-infrared photonics with phase-transition materials

McLeod, Alexander (p. 7)

Insulator-metal phase coexistence probed by cryogenic near-field microscopy

Waser, Rainer (p. 8)

Fundamental ingredients of redox-based memristive switching in metal oxides

Wuttig, Matthias (p. 9)

Novel Phase Change Materials by Design: The Mystery of Resonance Bonding

Contributed Talks

Abendroth, Barbara (p. 10)

Effect of ion-induced defects on the electronic transport properties of ALD thin films in the system $\text{TiO}_2\text{-SrTiO}_3$

Gemming, Sibylle (p. 11)

Resistive oxides and the role of defects on the 5th anniversary of MEMRIOX

Krüger, Stephan (p. 12)

What Researchers need to know about Technology Transfer, Validation, and Exploitation

Rensberg, Jura (p. 13)

In-situ electrical characterization of ion beam irradiated wire- and layer-like VO_2 structures

Schmidt, Heidemarie (p. 14)

Ion irradiated, non-volatile, analog resistive oxide switches for neuromorphic computing and fuzzy logics

Slesazeck, Stefan (p. 15)

The diversity of Nb_2O_5 -based Memristors

Slesazeck, Stefan (p. 16)

The negative aspects at the origin of hysteresis effects in FeFETs and niobium threshold switches

You, Tiangui (p. 17)

Non-volatile resistive switching in BiFeO_3 -based thin films and the reconfigurable logic application

Poster Contributions

see list on page 18

Controllable Conduction at Complex Oxide Interfaces

Ying-Hao Chu^{1,2,3}

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Complex oxide interfaces emerge as one of the most exciting subjects among condensed matters due to their unique physical properties and new possibilities for next-generation electronic devices. Three types of complex oxide interfaces have been established. Among them, the most explored interface is the artificially constructed heterointerfaces. Various interactions at the interface have resulted in a number of exciting discoveries, such as highly mobile quasi-two dimensional electron gas (2DEG) forming between two band insulators (LaAlO_3 and SrTiO_3). Moreover, in ferroic oxides, domain walls dictate natural homo-interfaces as a consequence of the minimization of electrostatic and elastic energies. Several key studies have pointed out interesting observations, such as local conduction, on domain walls in multiferroics. Recently, new tubular oxide interface has been developed in the self-assembled heterostructures and the local conduction at the tubular interfaces of BiFeO_3 (BFO)- CoFe_2O_4 (CFO) heterostructure was found. Such results create a huge playground to explore and design intriguing properties of complex oxide interfaces. However, in the push for practical applications, it is desirable to have the control of the interface functionalities through external stimulus. In this presentation, a nonvolatile modulation of the local conduction at the homo- (BFO domain walls) and heterointerfaces ($\text{LaAlO}_3/\text{SrTiO}_3$) will be demonstrated. By inserting a ferroelectric layer, the polarization can tune and modulate the conduction at the $\text{LaAlO}_3/\text{SrTiO}_3$ heterointerface. The XPS and XSTM/S results reveal the electrostatic predictions of the conducting state modulation, demonstrating the possibility of non-volatile control. In addition, we went back to the BFO-CFO tubular interfaces and showed the interface conduction can be modulated non-volatily and reversibly via an external electric field by using conducting AFM. A memristive-like electronic conduction was observed, that is strongly correlated to the motion of oxygen vacancies (donor impurities) at the interface and in turn modifies the junction characteristics between the measurement tip and the interface. Our results complete the control of the conduction at complex oxide interfaces and suggest the possibility for new devices based on complex oxide interfaces.

Massimiliano Di Ventra

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Memcomputing: a brain-inspired topological computing paradigm

Which features make the brain such a powerful and energy-efficient computing machine? Can we reproduce them in the solid state, and if so, what type of computing paradigm would we obtain? I will show that a machine that uses memory to both process and store information, like our brain, and is endowed with intrinsic parallelism and information overhead - namely takes advantage, via its collective state, of the network topology related to the problem - has a computational power far beyond our standard digital computers [1]. We have named this novel computing paradigm “memcomputing” [2]. As an example, I will show the polynomial-time solution of prime factorization and the NP-hard version of the subset-sum problem using polynomial resources and self-organizing logic gates, namely gates that self-organize to satisfy their logical proposition [3]. I will also show that these machines are described by a Witten-type topological field theory and they compute via an instantonic phase where a transient long-range order develops due to the effective breakdown of topological supersymmetry [4]. The digital memcomputing machines that we propose are *scalable* and can be easily realized with available nanotechnology components, and may help reveal aspects of computation of the brain.

[1] F. L. Traversa and M. Di Ventra, **Universal Memcomputing Machines**, *IEEE Transactions on Neural Networks and Learning Systems*, 26, 2702 (2015).

[2] M. Di Ventra and Y.V. Pershin, **Computing: the Parallel Approach**, *Nature Physics*, 9, 200 (2013).

[3] F. L. Traversa and M. Di Ventra, **Polynomial-time solution of prime factorization and NP-hard problems with digital memcomputing machines**, *arXiv:1512.05064*.

[4] M. Di Ventra, F. L. Traversa and I.V. Ovchinnikov, **Topological field theory and computing with instantons** (in preparation).

Tunable mid-infrared photonics with phase-transition materials

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This talk will review our efforts to utilize phase-transition materials in mid-infrared optics and highlight relevant related literature. Materials like vanadium dioxide (VO_2) and rare-earth nickelates undergo structural and electronic phase transitions that can be driven via thermal, electrical, and optical means. These phase transitions result in dramatic changes in electronic properties, and correspond to large changes in optical properties, especially in the mid-infrared spectral range where the Drude response dominates. Previously we have demonstrated that VO_2 integrated into thin film structures enable temperature- and current-tunable absorbers and reflectors and plasmonic antennas, as well as thermal emitters with anomalous temperature dependence.

More recently, we looked to expand the palette of tunable optical materials by defect engineering VO_2 to alter its properties, and by using less-studied phase-transition materials such as samarium nickelate (SNO). By combining these approaches, thermally driven phase transitions can be found over a range of critical temperatures from below room temperature to above 100 °C. We are currently demonstrating anomalous thermal emitters using SNO, which can mask the temperatures of objects from thermal imagers, and VO_2 -based metasurfaces with new functionalities using nanoscale defect engineering with ion irradiation.

Many thanks to the contributions of numerous students, colleagues, and collaborators, including Chenghao Wan, Patrick Roney, Jad Salman, Alireza Shamsafi, Jura Rensberg, Carsten Ronning, You Zhou, Zhen Zhang, Shriram Ramanathan, Shuyan Zhang, and Federico Capasso.

Cryogenic nano-optical imaging of the insulator-metal transition in correlated oxides

A. S. McLeod^{1*}, E. van Heumen², J. Zhang¹, K. W. Post¹, J. G. Ramirez¹, S. Wang¹, T. Saerbeck¹, S. Guenon¹, M. Goldflam¹, M. K. Liu¹, M. Hepting³, W. B. Wu⁴, R. Averitt¹, B. Keimer³, I. K. Schuller¹, and D. N. Basov¹

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While insulator-metal transitions remain among the most studied phenomena in correlated electron physics, their interplay with spatially ordered phase coexistence at the meso- and nano-scales remains poorly understood in realistic materials. Enabled by cryogenic near-field infrared microscopy, we reveal real-space evolution of the low temperature insulator-metal transitions in thin films of the correlated transition metal oxides: V_2O_3 , $NdNiO_3$, and $La_{2/3}Ca_{1/3}MnO_3$. The canonical Mott transition in V_2O_3 is observed to proceed through two real-space textures: First, spontaneous formation of insulator-metal stripes is attributed to accommodation strain from an underlying structural transition, whereas a distinct “droplet” nano-texture dominates at lower temperatures, consistent with the role of long-range Coulomb interactions. Comparison with bulk electronic and structural probes reveals an associated thermal separation of structural and Mott transitions in this epitaxial compound. Such droplet nano-texture again manifests in $NdNiO_3$ upon a first-order transition into a low-temperature charge-transfer insulator state. Nucleation and growth of the high-temperature metallic state is then clearly resolved emerging from both defects/impurities and evident magnetic domain walls. Lastly, in the canonical magnetoresistive oxide $La_{2/3}Ca_{1/3}MnO_3$ we demonstrate that low-temperature metallic ferromagnetism can be inhibited through epitaxial strain, then reversibly restored on command by ultrafast photo-excitation. Through nano-scale imaging, we reveal the process of 1) photo-patterning and 2) reconfigurably erasing the magnetic metal, as mediated through unforeseen magneto-elastic coupling. Our studies demonstrate the unmatched utility of cryogenic nano-optical imaging for unraveling the mysteries of insulator-metal transitions among correlated oxides.

Fundamental ingredients of redox-based memristive switching in metal oxides

Rainer Waser, Felix Gunkel, Regina Dittmann, Vikas Rana, Dirk Wouters,
Ilia Valov, and Stephan Menzel

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Redox-Based Resistive Switching Memories (ReRAM), also called *nanoionic* memories or *memristive* elements, are widely considered to provide a potential leap beyond the limits of Flash (with respect to write speed, write energies) and DRAM (with respect to scalability, retention times) as well as energy-efficient approaches to neuromorphic concepts.

In this seminar talk, fundamental aspects of the physics and chemistry (lattice disorder, ionic and electronic transport processes, and phase formation) of these elements will be presented. In particular, the ultra-high non-linearity of the switching kinetics of redox-based resistive switching devices will be discussed with an emphasis on the so-called valence change mechanism (VCM) typically encountered as a bipolar switching in metal oxides. The involved electrochemical and physical processes can be either electric field/voltage enhanced or accelerated by a local increase in temperature due to Joule heating. The analysis of the published SET switching kinetics data of VCM-type ReRAM systems showed that their nonlinearity is mainly dominated by temperature-accelerated ion hopping, controlled by the local power during the switching process. The gradual RESET transition can be explained in terms of temperature-accelerated ion movement with counter-acting ion drift and diffusion processes. It will be shown that a designated combination of oxides can significantly improve the long-term kinetics, i.e. the retention time, by tailoring the ion diffusion properties in the oxide layers.

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Novel Phase Change Materials by Design: The Mystery of Resonance Bonding

M. Wuttig

RWTH Aachen University of Technology, Germany

Phase change media utilize a remarkable property portfolio including the ability to rapidly switch between the amorphous and crystalline state, which differ significantly in their properties. This material combination makes them very attractive for data storage applications in rewriteable optical data storage, where the pronounced difference of optical properties between the amorphous and crystalline state is used. This unconventional class of materials is also the basis of a storage concept to replace flash memory. This talk will discuss the unique material properties, which characterize phase change materials. In particular, it will be shown that only a rather small group of materials utilizes resonance bonding, a particular flavour of covalent bonding, which can explain many of the characteristic features of phase change materials. This insight is employed to predict systematic property trends and to explore the limits in stoichiometry for such memory applications. It will be demonstrated how this concept can be used to tailor the electrical and thermal conductivity of phase change materials. Yet, the discoveries presented here also force us to revisit the concept of resonance bonding and bring back a history of vivid scientific disputes about ‘the nature of the chemical bond’.

Effect of the microstructure characteristics on the electronic transport properties of ALD thin films in the system $\text{TiO}_2\text{-SrTiO}_3$

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Transition metal oxide thin films with compositions ranging from SrTiO_3 to TiO_2 constitute a model system to study the effects of microstructure characteristics on optic and electric properties of the dielectric. In particular, this work focused on the electronic transport and resistance changes in asymmetric metal insulator metal (MIM) stacks with the dielectric embedded between a non-reactive ohmic TiN bottom electrode and a noble Au top electrode. Modification of the dielectric microstructure is achieved on the one hand by means of thin film deposition conditions and on the other hand by noble gas ion implantation.

Atomic layer deposition (ALD) has been used to deposit the dielectric thin films. Since ALD allows for independent control of the cation metal organic precursors, ternary $\text{Sr}_x\text{Ti}_y\text{O}_z$ can be grown far off the thermodynamic equilibrium composition of SrTiO_3 . ALD of ternary $\text{Sr}_x\text{Ti}_y\text{O}_z$ at temperatures up to 320 °C always results in amorphous films of low leakage currents. Based on the cation stoichiometry, band gap, dielectric constant and barrier heights can be tuned between the values of TiO_2 and SrO. For binary TiO_2 the ALD temperature controls the formation of crystalline phases during growth. The presence of crystalline grains and grain boundaries affects leakage current as well as resistive switching of such layers.

Ion implantation introduces point defects such as vacancies, dangling bonds or a deviation from ideal cation coordination. Implantation parameters have been chosen to prevent preferential oxygen removal in near-surface regions as well as interface mixing with the bottom electrode. Hence the oxide stoichiometry is maintained and the effect of point defects on electronic transport properties is investigated independently from stoichiometry as a function of implantation dose.

The presentation will summarize the results accomplished during the VI Memriox PhD project of Solveig Putzschke.

Resistive oxides and the role of defects or the 5th anniversary of MEMRIOX

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Transition metal oxides exhibit a wealth of physical phenomena, among them ferroic properties such as ferroelasticity, ferroelectricity and ferromagnetism, or their combination in multiferroics. Ideal multiferroics may relax back to their field-free ground state, once the external field is removed. Thus, any information encoded by the field as local change of a materials' order parameter remains volatile. However, transition metal oxides are also sensitive to further environmental changes such as temperature, pressure, irradiation with light, the external partial pressure of oxygen or – as targeted specifically in the present framework – by the bombardment with ions. Changing one or more of those extrinsic parameters induces structure changes, stoichiometry deviations, modifications of the magnetic ordering and, most importantly, local variations of the electric conductivity. Extended intrinsic imperfections such as vacancy clusters, dislocations, structural grain boundaries, ferroic domain walls or heterophase interfaces are excellent trap sites to attract mobile charged species. In this way, regions of locally enhanced conductivity can percolate to current paths in a non-volatile way. Return to the pristine state may be driven by the entropy gain, when those conductive species are released from the current-leading paths by temperature and/or field effects.

Within the MEMRIOX cooperation particular emphasis has been put on the controlled formation and operation of such reversibly conducting regions with high spatial precision. Two routes have been followed to achieve spatial resolution: the targeted local modification with the help of ion beams and the use of nanowires and very thin films. The presentation will first summarize mostly experimental results on the resistive properties of material stacks for resistive devices and the influence of ion-beam treatment on such systems. The second part will focus on the microscopic picture of materials' changes in the vicinity of structural imperfections, which are accessible to modeling from first-principles.

Mainly ternary compounds from the perovskite and spinel families will be discussed as examples, which correlate local changes due to point and planar defects with changes of the elastic, polarization and magnetic properties. The microscopic interactions are determined by density functional calculations, which yield the basis for more large-scale simulations with effective Hamiltonian approaches. Examples include the field-induced migration of oxygen vacancies in SrTiO₃, the complex domain wall behavior in epitaxially strained SrMnO₃ and the interplay between epitaxy strain, local ion-beam-induced structure changes and vacancy formation in NiCo₂O₄, which has a series of complex antiferromagnetic phases coexistent with ferroelectricity.

What Researchers need to know about Technology Transfer, Validation, and Exploitation

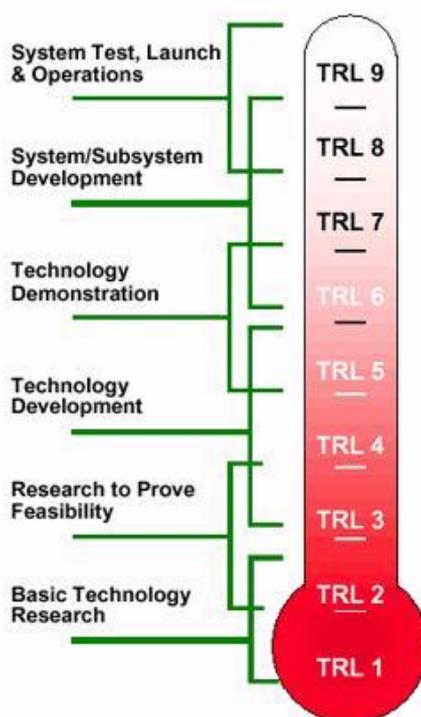
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Abstract

Exploitation-wise, Research & Development can be grouped into different technology readiness levels (TRL). Where do you group your Memriox` results and how do you pave the way to stunning applications?



At November 21st /22nd, 2016 there will be an Innovation Forum, held in Dresden, concerning one of the essential parts of Memriox – the BFO topic. The Innovation Forum aims to attract investors and industry: www.charged-oxides.com

In-situ electrical characterization of ion beam irradiated wire- and layer-like VO₂ structures

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One of the most interesting and widely studied phase-transition materials is vanadium dioxide (VO₂), which exhibits an insulator to metal transition (IMT) upon heating above a critical temperature of $T_C \sim 68$ °C. The high-speed reversible transition in the order of nanoseconds makes this material very promising for integrated devices like ultra-fast switches, sensors, or memories [1]. The growth of high-quality VO₂ thin films with bulk-like electronic properties and high crystalline quality is still challenging. Enormous strains exist at the interfaces, mainly due to the differences in the crystal lattice parameters and thermal expansion coefficients between film and substrate, resulting in a broadening of the phase transition region. In contrast, stress can easily relax during the growth of nanostructures via unconstrained surfaces, making VO₂ nano-/microwires an ideal model system with very high crystal quality and sharp phase transitions.

Here, we compare in-situ temperature dependent electrical characterization of VO₂ thin films and microwire structures during ion irradiation. The experiment is complimented by temperature dependent optical and structural characterization using reflectance measurements, Raman spectroscopy, and X-Ray diffraction. We demonstrate how - independent on the geometry - ion beam irradiation can be used to modify and engineer the IMT via the intentional creation of defects and lattice damage.

Unlike existing means to modify the IMT via doping during growth, ion beam irradiation can be combined with lithographic patterning to create complex electrical and optical devices on a subwavelength scale [2]. Thermal annealing shows, that this type of defect engineering is a robust method to engineer the phase transition and greatly expands the utility of phase-change materials.

[1] M. Soltani *et al.*, Applied Physics in the 21st Century (2008).

[2] J. Rensberg *et al.*, Nano Letters **16**,1055 (2016).

Ion irradiated, non-volatile, analog resistive oxide switches for neuromorphic computing and fuzzy logics

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The ongoing research towards non-volatile memory devices has inspired many researchers to investigate different switching mechanisms, e.g. resistive switching [1] and capacitive switching [2], in oxide thin films. Here we present nonvolatile resistive switching without an electroforming process in two-terminal Ti-doped bismuth ferrite (BiFeO_3) thin film structures [1]. Fixed Ti donors can effectively trap mobile donors in BiFeO_3 if a writing voltage is applied [3]. The concentration of mobile and fixed donors is controlled during the BiFeO_3 thin film synthesis, e.g. by Ar^+ [4] and Ti^+ ion irradiation. In a proof-of-principle experiment for BiFeO_3 structures with one flexible and one unchangeable electrode we have demonstrated fast and energy-efficient spike-timing dependent plasticity (STDP) for learning [5] and higher harmonics generation for hardware-based cryptography [6]. For BiFeO_3 structures with two flexible electrodes we have demonstrated the nonvolatile reconfiguration of all 16 Boolean logic gates for application in binary logics [7] and in fuzzy logics. Furthermore, four learning curves have been realized with the same analog resistive oxide switch and application for complementary learning is discussed.

[1] Y. Shuai et al., Appl. Phys. Exp. 4 (2011); J. Appl. Phys. 109 (2011)

[2] T. You et al., Adv. Electron. Mater. 2 (2016)

[3] T. You et al., ACS Applied Materials & Interfaces 6 (2014);

[4] X. Ou et al., ACS Appl. Mater. Interfaces 5 (2013)

[5] N. Du et al., Front Neurosci. 9 (2015)

[6] N. Du et al., J. Appl. Phys. 115 (2014)

[7] T. You et al., Adv. Funct. Mater. 24 (2014)

The negative aspects at the origin of hysteresis effects in FeFETs and niobium threshold switches

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Recent discovery of ferroelectricity in thin hafnium oxide films has led to a resurgence of interest in ferroelectric memory devices. The electrical characteristic of these ferroelectric capacitors with hysteretic capacitance can be described as a kind of memcapacitor. However, besides the multi-domain characteristic typically measured in MFM structures, first evidence for single domain switching in ultra-scaled ferroelectric field effect transistors (FeFET) was revealed. Currently the underlying physical mechanisms are still under debate. The occurrence of a negative differential capacitance effect might explain the hysteretic switching behavior, yielding the memory window in FeFETs.

A completely different kind of device are the niobium oxide based volatile threshold switching memristors, which have been gaining interest due to their potential application as ReRAM selector elements. This devices exhibit a switching hysteresis in their IV-characteristic originating from the emergence of a negative differential resistance effect. Even though, negative resistance and negative capacitance effects stem from completely different physical effects, the characterization and modeling approaches have some commonalities. In my talk I will discuss our approaches to characterize these devices. Further, I will shed some light on new opportunities which might arise from the infinitesimal gain of energy in the 'negative differential' regions, such as the realization of steep-sub-threshold devices and self-sustaining oscillators.

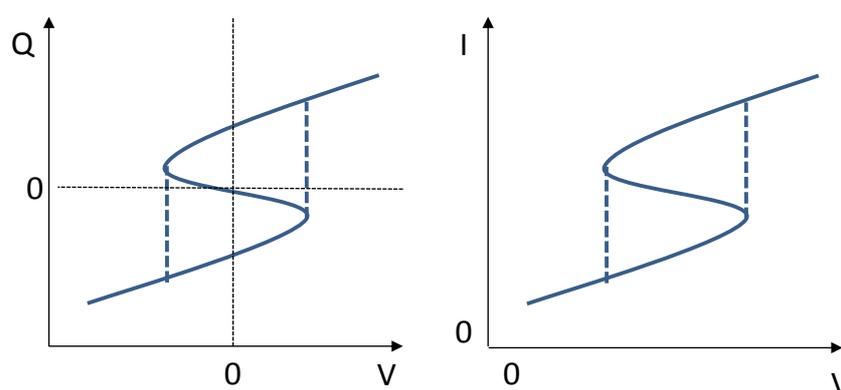


Fig. 1: Illustration of negative differential capacitance and negative differential resistance

The diversity of Nb2O5-based Memristors

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Niobium oxide based memristor devices exhibit various electrical characteristics such as non-volatile analog or more digital abrupt memory switching and the volatile threshold switching. The electrical characteristic of the resistance switching devices depends not only on the device configuration, such as the oxide stoichiometry and crystallinity or the electrode material, but also on the electrical excitation. Furthermore, there are different manufacturing processes to realize the different device types, including ion implantation to locally change the oxides stoichiometry. In our talk we will give an overview on the different memristor characteristics which we realized in course of our Memriox activities. From the results we will emphasize that the niobium oxide system is a suitable model system to analyze different switching mechanisms which might occur in other material systems as well. In particular, the threshold switching effect in Niobium oxide is found to be independent of the material specific effect of metal-insulator-transition at 1070 K, but can be explained by a trap-assisted Frenkel-Poole like conduction mechanism in combination with a moderate temperature increase by only 150 K due to Joule heating. A physics based model of pure electrical nature explains the occurrence of the threshold effect as well as the negative-differential resistance behavior observed in Niobium oxide. The threshold switching might be at the origin of abrupt memory switching effects which are observed in many other commonly used material systems such as the Tantalum or Hafnium oxide devices.

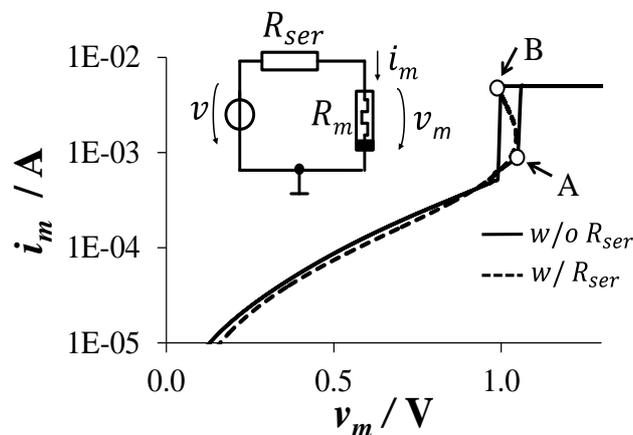


Fig. 1 Quasi-static i_m - v_m characteristic of the threshold switching device with and without a stabilizing resistor of value $R_{ser} = 330\Omega$. The inset shows the measurement circuit with series resistor.

Non-volatile resistive switching in BiFeO₃-based thin films and the reconfigurable logic application

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Resistive switching devices are considered as one of the most promising candidates for the next generation memories and nonvolatile logic applications. This provides the possibility to carry out the processing and storage simultaneously and at the same resistive switching devices, which could offer very significant performance benefits and overcome the von-Neumann bottleneck.^[1,2] In this work, bipolar resistive switching was observed in polycrystalline BiFeO₃ (BFO), BiFeO₃:Ti (BFTO), and BFO/BFTO thin films which were fabricated by pulsed laser deposition. The resistive switching mechanism is understood by a model of complementary tunable height of top and bottom Schottky-like barrier due to the mobile and fixed donors in BFO-based thin films.^[3-5] It is expected that the oxygen vacancies act as the mobile donors which can be redistributed under the writing bias to change the Schottky barrier heights, and Ti atoms act as the fixed donors which can effectively trap and release oxygen vacancies and consequently stabilize the resistive switching in BFO-based thin films. The BFO/BFTO bilayer structures show stable and nonvolatile resistive switching behavior in both positive and negative bias.^[4] Different from the conventional bipolar resistive switching, the resistance state of BFTO/BFO bilayer structures not only depends on the writing bias, but also on the polarity of reading bias. For the reconfigurable logic applications, the polarity of the reading bias can be used as an additional logic variable, which makes it feasible to program and store all 16 Boolean logic functions simultaneously and into a same single cell of BFTO/BFO bilayer structure in three logic cycles. This promises a most efficient and effective means for implementing beyond von-Neumann computing.

[1] J. Bachus, *Commun. ACM*, 1978, **21**, 613

[2] T. Hasegawa, et al., *Adv. Mater.*, 2010, **22**, 1831

[3] T. You, et al., *ACS Appl. Mater. Interfaces*, 2014, **6**, 19758

[4] T. You, et al., *Adv. Funct. Mater.*, 2014, **24**, 3357

[5] T. You, et al., *Sci. Rep.*, 2015, **5**, 18623

Your Notes

Posters

updated: 14.09.2016 (PZ)

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Structural and electrical characterization of ALD grown HfO₂ thin films

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Abstract

HfO₂ films were grown on 4-inch native SiO₂/Si wafers by Atomic Layer Deposition (ALD) from tetrakis(dimethylamido)hafnium and deionized water in a Savannah S100 system. The temperature was varied from 100 °C to 350 °C in steps of 50 K. All other ALD process parameters were fixed. The resulting HfO₂ layers were characterized in terms of thickness homogeneity, growth rate per cycle, surface roughness, crystal structure, stoichiometry, mass density, optical bandgap, and index of refraction. Based on the obtained growth rate of HfO₂ on SiO₂/Si, 25 nm thick HfO₂ layers were grown on Pt/Ti/SiO₂/Si substrates for electrical characterization. Furthermore, the most important structural properties were compared for the growth of HfO₂ on Pt/Ti/SiO₂/Si and SiO₂/Si substrates.

HfO₂ breakdown voltages show a clear decrease with increasing growth temperature, which was correlated to the crystallinity of the films due to the preferred breakdown along grain boundaries. With respect to resistive switching, an amorphous HfO₂ layer grown at 150 °C was compared to a crystalline one grown at 300 °C. Furthermore, resistive switching characteristics were tuned by the use of two different top electrode materials, namely an inert Pt or a reactive Ti/Pt electrode. The contact diameter was 50 μm. In the majority of cases, the resistive switching mode was found to be unipolar. Only the combination of a crystalline HfO₂ layer with an inert Pt bottom and a reactive Ti/Pt top electrode led to a “pseudo-bipolar” switching mode with a convertible SET and RESET polarity.

The project is funded by the Initiative and Networking Fund of the Helmholtz Association (Virtual Institute Memriox, VH-VI-422).

Giant resistive switching by conductive domain walls in exfoliated thin-film lithium niobate

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We investigate the formation of conductive domain walls (CDWs) in exfoliated thin-film lithium niobate ($d = 600$ nm) on a global Pt back-electrode under both Cr/Au plane electrodes ($A \sim 200\mu\text{m}^2$) as well as sharp Pt-AFM probes ($A \sim 300\text{nm}^2$). We observe a very distinct and abrupt increase in the conductivity over at least 5 orders of magnitude at $V_{\text{set}} = 21.05$ V. The set voltage V_{set} is as precisely defined as $\Delta V_{\text{set}}/V_{\text{set}} < 10^{-3}$. The set-voltage was sufficiently correlated with the coercive voltage in the material by switching-spectroscopy (ss) PFM. Plane electrode and AFM-based resistive switching were sufficiently found to be correlated to the formation of CDWs both by local cAFM and PFM measurements. ssPFM shows the coercive voltage to be very homogeneously distributed in the single crystalline film ($\Delta V_c < 1$ V) with a small internal field. Scanning microwave impedance microscopy (sMIM) and comparative FEM simulation reveal a clear increase in conductivity at the domain wall from 10^{-8} S/m to 10^3 S/m, which gives a significantly larger ratio of 10^{11} as the background is distinctly measurable.

The application of CDWs for resistive switching devices was investigated. We were able to measure a stable on- and off-current over 10^4 s in the metal-ferroelectric-metal stack at read-voltages < 10 V. It was possible to cycle the device for as much as 10^5 cycles with a resistance window of 10^4 . The read-current in such a device was tunable both by writing voltage and time with a variation of 10^2 . The transport mechanism was found to be space-charge limited current both by direct I - V curve analysis as well as by $d\log(I)/dV$.

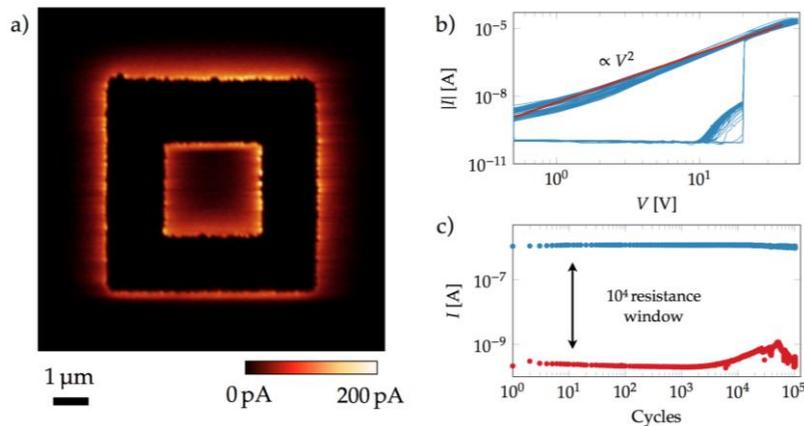


Fig. 1: Resistive switching by ferroelectric domain walls in lithium niobate a) conductive AFM measurement at $V = 3$ V, b) 100 cycles of current-voltage (I - V) curves on metal-ferroelectric-metal stack c) cyclic resistive switching with a read-out voltage $V_{\text{read}} = 10$ V.

Open volume defects in annealed and ion irradiated SrTiO₃ systems

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The formation of vacancies in SrTiO₃ due to annealing in vacuum [1] or low-energy ion irradiation [2] also leads to the modification of electronic properties that could be exploited in applications like resistivity switching. Here, we employ both these modification methods combined with in-situ defects evolution analysis by means of Doppler Broadening Positron Annihilation Spectroscopy (DB-PAS). Two reference SrTiO₃ single crystals, undoped and Nb-doped have been investigated. Vacuum annealing of undoped SrTiO₃ increases the defect concentration which can be attributed to the creation of oxygen and strontium vacancies close to the sample surface and deeper inside the substrate, respectively. Variable energy DB-PAS reveals the depth-dependent open volume defects concentration. Second, in-situ room and low temperature (about 165K) Ar⁺ irradiation has been utilized as a preliminary attempt to understand a vacancy migration process beneath the kinetical ion penetration depth. For that purpose, a frozen vacancy state is required, which could be achieved by lowering the system temperature below the vacancy activation energy. Although, that part of the experiment has been not entirely successful due to not low enough temperature realized during ion irradiation, however, a strong conclusion has been drawn about necessity of performing such type of experiments *in-situ*. A clear indication of oxygen deficiency at the sample surface due to ion irradiation, as found from DB-PAS is diminished after repeated *ex-situ* measurements.

[1] T. Nestler, *et al.*, Appl. Phys. A, **105**, 103 (2011)

[2] G. Herranz, *et al.*, J. Appl. Phys. **107**, 103704 (2010)

Domain walls in SrMnO₃ thin films under epitaxial tensile strain

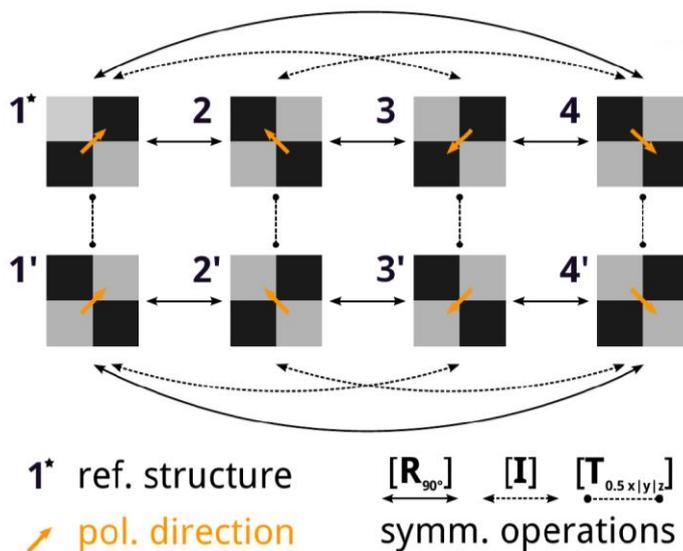
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Strontium manganate (SrMnO₃), a perovskite polymorph, exhibits cubic structure at low temperatures, which transforms into a hexagonal one at high temperatures. Density-functional calculations showed earlier, that under tensile strain the ground state of bulk SrMnO₃ corresponds to a G-type-antiferromagnetic (G-AFM) cubic structure. If deposited as epitaxially strained thin film a rearrangement of the MnO₆ coordination polyhedra was calculated, which is antiferrodistortive in the plane parallel to the substrate [1]. Recently, ferroelectric domains have been observed experimentally in thin films of SrMnO₃ (20 nm) on (001)-oriented LSAT with a 1.7 % tensile strain [2]. Strikingly, the domain walls were found to be electrically insulating, rendering the domains to form stable nano-capacitor.



The local polarization direction in the domains and polarization profile across the domain walls is not known experimentally. Given the fact that the ground state building block for the supercell possesses four rotational and two translation degrees of freedom, about twenty-eight different configurations for the supercell structure are possible. We employ group theoretical analysis to filter out the at-most unique configurations of the domain walls with both SrO₂ and MnO₂ termination planes. Concurrently, we present a first-

principle investigation of the domain wall formation energies and the structural and electronic properties in these unique configurations.

As outlook, we present first results on the effect of vacancies and defects on the energetic and conductance properties of such domain walls.

1) J. H. Lee *et al.*, PRL **104**, 207204 (2010).

2) C. Becher *et al.*, Nature Nanotechnology **10**, 661 (2015).

A new ion-beam laboratory at the Slovak University of Technology

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An ion beam laboratory has been commissioned recently at the Slovak University of Technology within the University Science Park CAMBO located in Trnava. The facility will serve research in the field of materials science, physical engineering and nanotechnology. Two systems have been put into operation. First, a 6MV Tandetron electrostatic tandem accelerator equipped with Cs-sputtering and Duoplasmatron ion sources and end-stations for high energy ion-beam implantation as well as ion-beam analysis with RBS, PIXE, ERDA analytical systems. Second, a 500kV implanter equipped with a Bernas type ion source and two experimental wafer processing end-stations. The facility, first experiments and near future development plans are presented.

High Magnetic Moment in Ferrimagnetic NiCo₂O₄ films via He Ion Irradiation

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The spinel NiCo₂O₄ (NCO) exhibits unique combination of electrical conductivity, infrared transparency, electro catalytic activity, and ferrimagnetic order, which makes it an attractive material for spintronic applications.¹ The NCO thin-films electrical and magnetic properties can be manipulated from high temperature ferrimagnetic and metallic to low temperature ferromagnetic and insulating by changing the growth temperature.² The high quality epitaxial NCO films were grown on MgAl₂O₄ (100) substrate at ~ 400°C exhibits metallic behavior accompanied by ferrimagnetic order with moment ~ 2 μ_B/fu.^{1,2} Here, we report the impact of He-ion irradiation with fluence ranging from 5×10¹⁵/cm² – 3×10¹⁶/cm² on these metallic NCO films. The use of He-ion irradiation results in the coherent control of out-of-plane lattice parameter of these films without changing its in-plane lattice parameter (Figure 1). The comprehensive study of magnetization data reveals the magnetic moment increases drastically to ~ 4 μ_B/fu (Figure 1). The X-ray absorption spectroscopic study also suggests the possible charge redistribution within the octahedral sites of the NCO films which corroborates well with the increase in the magnetic moment.

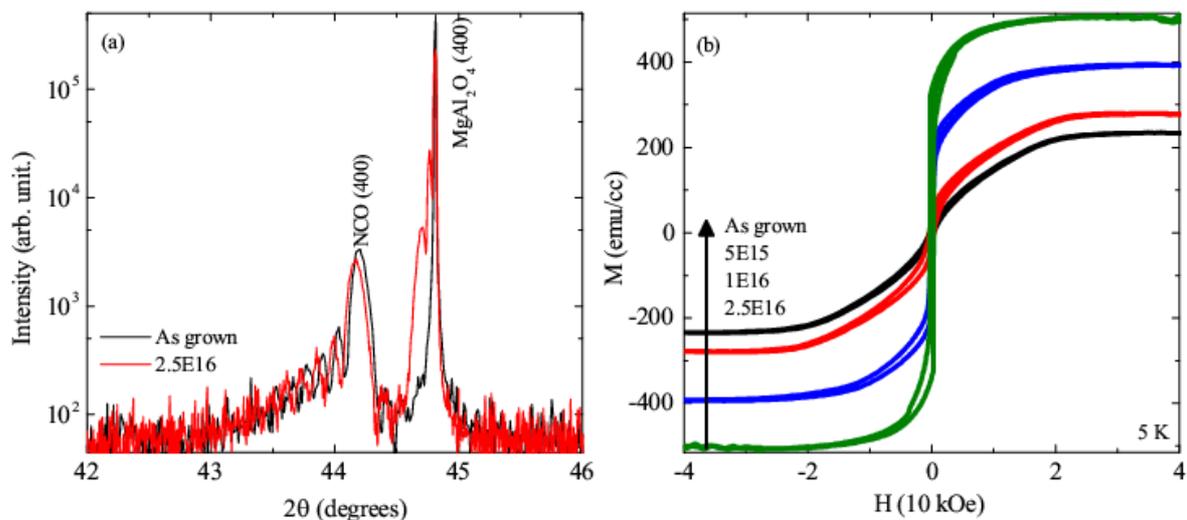


Figure 1: (a) θ - 2θ scan and (b) field (H) dependent magnetization (M) of as grown and the He-ion irradiated NCO films.

1. Punam Silwal *et al.*; *Appl. Phys. Lett.* **100**, 032102 (2012)
2. Yugandhar Bitla *et al.*; *Sci. Rep.* **5**, 15201 (2015)

Nonvolatile resistive switching to 10^5 ohms OFF/ON resistance ratio in yttrium manganite thin films with downscaled top electrodes

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Polycrystalline, hexagonal YMnO_3 (YMO) thin films grown by pulsed laser deposition (PLD) with the use of stoichiometric, ceramic YMO target, exhibit a nonvolatile unipolar resistive switching [1, 2]. In this work, we investigate the resistive switching properties of YMO thin films prepared by PLD with the use of ceramic YMO target of different chemical compositions on a large-scale Pt and Pt/Ti bottom electrode on SiO_2/Si substrates. Circular Au and Al top electrodes of different size have been prepared by magnetron sputtering and e-beam evaporation, respectively. All tested YMnO_3 -based structures show unipolar resistive switching (URS). URS depends on the ceramic target and bottom electrode. Endurance of YMO with Al top electrodes is improved in comparison to YMO with Au top electrodes. In addition, for large Al top electrodes and Pt and Pt/Ti bottom electrode URS with 10^2 - 10^4 and 10^1 - 10^3 OFF/ON resistance ratio has been realized, respectively. The phenomenon of increasing OFF/ON resistance ratio with decreasing size of Al top electrodes can be related with the dependence of R_{OFF} on electrode size, namely $R_{\text{OFF}}=10^6 \Omega$ for electrode diameter $260 \mu\text{m}$ and $10^4 \Omega$ for electrode diameter $800 \mu\text{m}$. R_{OFF} reflects decreased tendency for local shunting of YMO thin films in HRS.

[1] A. Bogusz et al., AIP Advances 4 (2014)

[2] A. Bogusz et al., Adv. Mater. Res. 1101 (2015)

Spatially selective ion irradiation- Tuning thin films into inherently flat metadevices

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Traditional plasmonic metamaterials comprising metallic structures exhibit unique electromagnetic properties not found in natural materials, such as the ability to efficiently harvest light, extraordinary transmission beyond the diffraction limit, and the ability to control the reflection or transmission direction of light beams. However, they still require complex designs and sophisticated fabrication procedures, and their bandwidth is fixed to narrow resonances and they exhibit low optical efficiency due to the inherent metal absorption losses.

Metasurfaces can also be created by using plane, ultrathin films on reflective substrates. By using the controllable abrupt phase shifts associated with reflection or transmission of light waves at the interfaces, such metasurfaces operate like optically thin cavities that strongly modify the light spectrum [1].

Here, we demonstrate that spatially selective defect engineering on the nanometer scale can transform thin films into optical metasurfaces. Using ion irradiation through nanometer-scale masks, we selectively defect-engineered the insulator-metal transition of vanadium dioxide, a prototypical correlated phase-transition material whose optical properties change dramatically depending on its state. We demonstrated several optical metasurfaces, including tunable absorbers with artificially induced phase co-existence and tunable polarizers based on thermally triggered dichroism.

[1] N. Yu *et al.*, *Nature Mat.* **13**, 139 (2014)

[2] J. Rensberg *et al.*, *Nano Letters* **16**, 1055 (2016).

Avalanche-discharge-induced electrical forming in Ta₂O₅ based MIM structures

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We investigated the resistive switching characteristics of Pt/ Ta₂O₅/Ta cells prepared by sputtering. Structural changes in the top electrode develops during the electrical forming process, which can be correlated to the formation of a dendrite-like conductive structure, which is induced by an avalanche discharge between the top electrode and the Ta₂O₅ layer, which occurs instead of a local breakdown between top and bottom electrode. The dendrite-like structure evolves primarily at structures with a pronounced interface adsorbate layer. Local conductive atomic force microscopy reveals that the entire dendrite region becomes conductive. We demonstrate by in-situ spectromicroscopy that the subsequent switching is caused by a valence change between Ta⁴⁺ and Ta⁵⁺, which takes place over the entire former Pt/ Ta₂O₅ interface of the dendrite-like structure.

Defect-induced magnetism in SiC probed by nuclear magnetic resonance

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It is still an open question whether a material with only *s* or *p* electrons can be magnetic. Recently, we showed that the defects in SiC, generated by neutron irradiation, introduce paramagnetism, the amplitude of which scales with the defect concentration [Phys. Rev. B **92**, 174409]. Here, we report on a ¹³C and ²⁹Si nuclear magnetic resonance (NMR) investigation of the defect-induced magnetism in SiC. Consistent with magnetization measurements, the temperature dependence of the NMR shift can well be described by a Curie-Weiss behavior for both nuclear isotopes, allowing for a detailed study of the electronic paramagnetism in SiC from a local probe point of view. The increasing line width of the NMR spectra upon cooling indicates a growing amplitude of the internal dipole fields stemming from the local moments. Simulations based on a local dipole field model were performed, and are compared to the amplitude of the experimental ¹³C and ²⁹Si NMR shifts and line widths. For comparison, NMR measurements were performed on a virgin sample of SiC without defects, and, as expected, no NMR signal was observed due to its gapped, non-magnetic nature. Our study provides clear indications of defect-induced magnetism in SiC.

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Defect induced magnetism in SiC

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Defect-induced magnetism is attracting intensive research interest. It not only challenges the traditional opinions about magnetism, but also has some potential applications in spin-electronics. SiC is a new candidate for the investigation of defect-induced ferromagnetism after graphitic materials and oxides due to its high material purity and crystalline quality [1, 2]. In this contribution, we made a comprehensive investigation on the structural and magnetic properties of ion implanted and neutron irradiated SiC sample. In combination with X-ray absorption spectroscopy and first-principles calculations, we try to understand the mechanism in a microscopic picture.

For neon or xenon ion implanted SiC, we identify a multi-magnetic-phase nature [3]. The magnetization of SiC can be decomposed into paramagnetic, superparamagnetic and ferromagnetic contributions. The ferromagnetic contribution persists well above room temperature and exhibits a pronounced magnetic anisotropy. By combining X-ray magnetic circular dichroism and first-principles calculations, we clarify that p-electrons of the nearest-neighbor carbon atoms around divacancies are mainly responsible for the long-range ferromagnetic coupling [4]. Thus, we provide a correlation between the collective magnetic phenomena and the specific electrons/orbitals.

With the aim to verify if a sample containing defects through its bulk volume can persist ferromagnetic coupling, we applied neutron irradiation to introduce defects into SiC [5]. Besides a weak ferromagnetic contribution, we observe a strong paramagnetism, scaling up with the neutron fluence. The ferromagnetic contribution only occurs in a narrow fluence window or after annealing. We speculate that defect-induced ferromagnetism rather locally appears in particular regions, like surface/interface/grain boundaries.

- [1] L. Li, et al., *Appl. Phys. Lett.* 98, 222508 (2011).
- [2] Y. Wang, et al., *Phys. Rev. B* 90, 214435 (2014).
- [3] Y. Wang, et al., *Phys. Rev. B* 89, 014417 (2014).
- [4] Y. Wang, et al., *Scientific Reports*, 5, 8999 (2015).
- [5] Y. Wang, et al., *Phys. Rev. B* 92, 174409 (2015).

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Updated: 13.09.2016 (PZ)

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